

## **CLAIM AMENDMENTS**

17. (new) An apparatus for liquid treating and drying at least one flat semiconductor substrate, said apparatus comprising in combination:

a tank, said tank comprising a wall with at least one hole and comprising at least one opening in a top section of said tank, said opening allowing passage of said substrate in a direction parallel to the plane of said substrate, said tank on the outside further comprising a gutter and a drain, the gutter on at least a portion of the tank, the drain connected to said gutter;

means for moving said substrate into said tank; and

means for moving said substrate out of said tank through said opening in an essentially vertical direction.

Applicants previously filed a check for \$852.00, which included the cost of filing claims 17-37 (21 claims), four of which are independent claims. The filing receipt indicated payment of \$750.00, 20 claims, and 1 independent claim. Applicants note that the pending independent claims are 17, 22, 33, and 35. As claim 1 has been canceled from this application, claims 33 and 35 will need to be rewritten in independent form. A credit of \$102.00 was made to the deposit account due to the error in canceling claim 17. A check for \$104.00 is enclosed for adding one additional claim over 20 and for one independent claim over 3. Please charge the Deposit Account No. 13-2490 for any additional fees.

Applicants respectfully request an updated filing receipt indicating that payment of \$854 has been received for 21 claims, 4 of which are independent.

Respectfully submitted,

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By:



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